



Zew

500.41316VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAJI, et al

Serial No.: ~~10/090,759~~ 10/659,394

Filed: September 11, 2003

For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS
AND PLASMA PROCESSING METHOD USING IT

Group: 1763

Examiner: P. Hassanzadeh

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 8, 2004

Sir:

In response to the Office Action dated June 8, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification;

Amendment of the Claims; and

Remarks are included following the amendments.